

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shinobu ISOBE et al.

Serial No.:

10/602,977

Filed: June 24, 2003

For:

Semiconductor Manufacturing Device and

Method Therefor

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

Examiner: Roy Karl Potter

Group Art: 2822

October 18, 2004

(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

October 18, 200 Date of Signature

Mail Stop Amendment Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

SIR:

Applicants hereby request a one-month extension of the original shortened statutory response period set in the Office Action of June 17, 2004. A check in the amount of \$110.00 in payment of the government fee for a one-month extension of time is enclosed herewith. Any additional fees or charges required at this time in connection with the present application may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

In response to the Office Action dated June 17, 2004, please consider the following items:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper; and

Remarks/Arguments which begin on page 3 of this paper.

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